传感材料与传感技术丛书

Sensing Material and Sensing Technology Series

# CHEMICAL SENSORS SIMULATION AND MODELING

**Volume 4 Optical Sensors** 

EDITED BY GHENADII KOROTCENKOV

影印版

化学传感器: 仿真与建模

第 4 卷 光学传感器

下册





必爾濱ノ業大學出版社 HARBIN INSTITUTE OF TECHNOLOGY PRESS

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### 黑版贸审字08-2014-079号

Ghenadii Korotcenkov

Chemical Sensors: Simulation and Modeling Volume 4: Optical Sensors

9781606503188

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Originally published by Momentum Press, LLC

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#### 图书在版编目(CIP)数据

化学传感器: 仿真与建模. 第4卷,光学传感器 = Chemical Sensors: Simulation and Modeling. Volume 4: Optical Sensors. 下册:英文/(摩尔)科瑞特森科韦(Korotcenkov, G.)主编. 一影印本. 一哈尔滨:哈尔滨工业大学出版社,2015.1

(传感材料与传感技术丛书)

ISBN 978-7-5603-4907-7

I.①化… II.①科… III.①化学传惑器-研究-英文 ②光敏传感器-研究-英文 IV.①TP212.2 中国版本图书馆CIP数据核字(2014)第244958号



责任编辑 杨 桦 张秀华 许雅莹

出版发行 哈尔滨工业大学出版社

社 址 哈尔滨市南岗区复华四道街10号 邮编 150006

传 真 0451-86414749

网 址 http://hitpress.hit.edu.cn

印 刷 哈尔滨市石桥印务有限公司

开 本 787mm×960mm 1/16 印张 18.5

版 次 2015年1月第1版 2015年1月第1次印刷

书 号 ISBN 978-7-5603-4907-7

定 价 90.00元



### PREFACE

This series, Chemical Sensors: Simulation and Modeling, is the perfect complement to Momentum Press's six-volume reference series, Chemical Sensors: Fundamentals of Sensing Materials and Chemical Sensors: Comprehensive Sensor Technologies, which present detailed information about materials, technologies, fabrication, and applications of various devices for chemical sensing. Chemical sensors are integral to the automation of myriad industrial processes and everyday monitoring of such activities as public safety, engine performance, medical therapeutics, and many more.

Despite the large number of chemical sensors already on the market, selection and design of a suitable sensor for a new application is a difficult task for the design engineer. Careful selection of the sensing material, sensor platform, technology of synthesis or deposition of sensitive materials, appropriate coatings and membranes, and the sampling system is very important, because those decisions can determine the specificity, sensitivity, response time, and stability of the final device. Selective functionalization of the sensor is also critical to achieving the required operating parameters. Therefore, in designing a chemical sensor, developers have to answer the enormous questions related to properties of sensing materials and their functioning in various environments. This five-volume comprehensive reference work analyzes approaches used for computer simulation and modeling in various fields of chemical sensing and discusses various phenomena important for chemical sensing, such as surface diffusion, adsorption, surface reactions, sintering, conductivity, mass transport, interphase interactions, etc. In these volumes it is shown that theoretical modeling and simulation of the processes, being a basic for chemical sensor operation, can provide considerable assistance in choosing both optimal materials and optimal configurations of sensing elements for use in chemical sensors. The theoretical simulation and modeling of sensing material behavior during interactions with gases and liquid surroundings can promote understanding of the nature of effects responsible for high effectiveness of chemical sensors operation as well. Nevertheless, we have to understand that only very a few aspects of chemistry can be computed exactly.

However, just as not all spectra are perfectly resolved, often a qualitative or approximate computation can give useful insight into the chemistry of studied phenomena. For example, the modeling of surface-molecule interactions, which can lead to changes in the basic properties of sensing materials, can show how these steps are linked with the macroscopic parameters describing the sensor response. Using quantum mechanics calculations, it is possible to determine parameters of the energetic (electronic) levels of the surface, both inherent ones and those introduced by adsorbed species, adsorption complexes, the precursor state, etc. Statistical thermodynamics and kinetics can allow one to link those calculated surface parameters with surface coverage of adsorbed species corresponding to real experimental conditions (dependent on temperature, pressure, etc.). Finally, phenomenological modeling can tie together theoretically calculated characteristics with real sensor parameters. This modeling may include modeling of hot platforms, modern approaches to the study of sensing effects, modeling of processes responsible for chemical sensing, phenomenological modeling of operating characteristics of chemical sensors, etc.. In addition, it is necessary to recognize that in many cases researchers are in urgent need of theory, since many experimental observations, particularly in such fields as optical and electron spectroscopy, can hardly be interpreted correctly without applying detailed theoretical calculations.

Each modeling and simulation volume in the present series reviews modeling principles and approaches particular to specific groups of materials and devices applied for chemical sensing. Volume 1: Microstructural Characterization and Modeling of Metal Oxides covers microstructural characterization using scanning electron microscopy (SEM), transmission electron spectroscopy (TEM), Raman spectroscopy, in-situ high-temperature SEM, and multiscale atomistic simulation and modeling of metal oxides, including surface state, stability, and metal oxide interactions with gas molecules, water, and metals. Volume 2: Conductometric-Type Sensors covers phenomenological modeling and computational design of conductometric chemical sensors based on nanostructured materials such as metal oxides, carbon nanotubes, and graphenes. This volume includes an overview of the approaches used to quantitatively evaluate characteristics of sensitive structures in which electric charge transport depends on the interaction between the surfaces of the structures and chemical compounds in the surroundings. Volume 3: Solid-State Devices covers phenomenological and molecular modeling of processes which control sensing characteristics and parameters of various solid-state chemical sensors, including surface acoustic wave, metal-insulatorsemiconductor (MIS), microcantilever, thermoelectric-based devices, and sensor arrays intended for "electronic nose" design. Modeling of nanomaterials and nanosystems that show promise for solid-state chemical sensor design is analyzed as well. Volume 4: Optical Sensors covers approaches used for modeling and simulation of various types of optical sensors such as fiber optic, surface plasmon resonance, Fabry-Pérot interferometers, transmittance in the mid-infrared region, luminescence-based devices, etc. Approaches used for design and optimization of optical systems aimed for both remote gas sensing and gas analysis chambers for the nondispersive infrared (NDIR) spectral range are discussed as well. A description of multiscale atomistic simulation of hierarchical nanostructured materials for optical chemical sensing is also included in this volume. *Volume 5: Electrochemical Sensors* covers modeling and simulation of electrochemical processes in both solid and liquid electrolytes, including charge separation and transport (gas diffusion, ion diffusion) in membranes, proton–electron transfers, electrode reactions, etc. Various models used to describe electrochemical sensors such as potentiometric, amperometric, conductometric, impedimetric, and ionsensitive FET sensors are discussed as well.

I believe that this series will be of interest of all who work or plan to work in the field of chemical sensor design. The chapters in this series have been prepared by well-known persons with high qualification in their fields and therefore should be a significant and insightful source of valuable information for engineers and researchers who are either entering these fields for the first time, or who are already conducting research in these areas but wish to extend their knowledge in the field of chemical sensors and computational chemistry. This series will also be interesting for university students, post-docs, and professors in material science, analytical chemistry, computational chemistry, physics of semiconductor devices, chemical engineering, etc. I believe that all of them will find useful information in these volumes.

G. Korotcenkov

## ABOUT THE EDITOR

**Ghenadii Korotcenkov** received his Ph.D. in Physics and Technology of Semiconductor Materials and Devices in 1976, and his Habilitate Degree (Dr. Sci.) in Physics and Mathematics of Semiconductors and Dielectrics in 1990. For a long time he was a leader of the scientific Gas Sensor Group and manager of various national and international scientific and engineering projects carried out in the Laboratory of Micro- and Optoelectronics, Technical University of Moldova. Currently, Dr. Korotcenkov is a research professor at the Gwangju Institute of Science and Technology, Republic of Korea.

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Dr. Korotcenkov's research activities have been honored by an Award of the Supreme Council of Science and Advanced Technology of the Republic of Moldova (2004), The Prize of the Presidents of the Ukrainian, Belarus, and Moldovan Academies of Sciences (2003), Senior Research Excellence Awards from the Technical University of Moldova (2001, 2003, 2005), a



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#### CHAPTER 7

# Novel Long-Period Fiber Grating Sensor Based on Dual-Peak Resonance and SPR

Zhengtian Gu

#### 1. INTRODUCTION

A long-period fiber grating (LPFG) is a kind of fiber device with photo-induced periodic modulation of the refractive index in the core, which was first reported in 1995 (Vengsarkar et al. 1996a). The periodicity of an LPFG is typically in the range of  $100-1000~\mu m$ . An LPFG can couple the fundamental core mode to the co-propagating cladding modes, producing a series of discrete attenuation peaks in the transmission spectrum. By virtue of advantages such as ease of fabrication, low insertion loss, low-level back reflection, and compactness, LPFGs have been used increasingly over the last few years in communications (Vengsarkar et al. 1996a, 1996b) and sensing applications (Bhatia and Vengsarkar 1996; Patrick et al. 1998; James and Tatam 2003).

Because the field distributions and effective refractive index (ERI) of the cladding modes are easily affected by the surrounding medium, LPFGs are very suitable for refractive index sensing (Lee et al. 1997; Tong et al. 2002; Chong et al. 2004). However, this kind of LPFG sensor is sensitive only to a surrounding medium whose refractive index is less than that of the silica cladding, and in addition, it is not species-specific, which limits the extent of its applications. Recently,

DOI: 10.5643/9781606503201/ch7 227

an LPFG chemical sensor whose cladding is coated with a sensitive thin film has been attracting much interest and attention. N. D. Rees coated an organicmaterial thin film on the cladding of an LPFG using Langmuir-Blodgett technique, and studied the influence of the thickness of the overlay material on the LPFG response (Nicholas et al. 2002). Ignacio et al. (2005, 2006), Wang et al. (2005), and Cusano et al. (2006) studied the resonance shift and the mode transition in high-refractive-index-coated long-period gratings. The theoretical analysis as well as experimental data suggest that the sensitivity of LPFG-based chemical/biosensors can be improved by appropriate choice of the cladding mode order, the film thickness, and the refractive index, and there is an optimum overlay thickness for each combination of ambient and overlay refractive indices. Based on this coated LPFG structure, Pilla et al. (2005), Gu et al. (2006), and Jesus et al. (2007) designed optical chemo-, gas-, and pH sensors. The coated LPFG sensors overcome the limitation of noncoated LPFGs that the refractive index of the external medium must be less than or equal to that of the cladding, and has the advantages of specification of chemical analyte and broad response range.

In 1999, Shu et al. (1999) found that when the grating period of an LPFG was short (~100  $\mu m$ ), dual resonance peaks of the higher cladding mode appeared during the writing process of the LPFG. They also found that the dual resonance wavelengths shifted in opposite directions with variation of the environmental refractive index. Based on this dual peak effect, Shu and Huang (1999) fabricated a kind of high-sensitivity liquid concentration sensor, for which the sensitivity of the LP $_{015}$  cladding mode is 20 times higher than that of the scheme with conventional grating period (400  $\mu m$ ). If the dual-peak resonance effect is utilized in an LPFG coated with a sensitive thin film, the LPFG not only has high sensitivity to refractive index, due to dual peak resonance, but also enlarges the sensing application range which can be applied in monitoring the solution concentration, gas concentration, and so on. When this kind of LPFG is brought into contact with the external surroundings, the change of refractive index of the thin film leads to variation of the interval between the dual resonance peaks. This coated LPFG based on dual peak resonance is first discussed in this chapter.

Surface plasmon resonance (SPR) is one of the promising optical techniques with potential applications in various fields (Flavio et al. 2005; Chen et al. 2005; Wang and Knoll 2006; Shin et al. 2007). SPR sensors have advantages such as flexibility, low cost, and small size (Lotierzo et al. 2004; Gupta and Sharma 2005). The principle of SPR sensors is that the surface plasmon wave (SPW), which can be excited at the interface between a metal film and an absorbing medium, is extremely sensitive to tiny changes in the refractive index (RI) of the absorbing medium. SPR sensors have been developed into three types: prism-coupled, integrated optical waveguide-coupled, and optical fiber-coupled sensors (Dostalek et al. 2001; Ho et al. 2001; Cao et al. 2006). In recent years, considerable attention has focused on SPR sensors based on metal-coated LPFGs, which are extremely